



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

September 24, 2025

IGI Report Number **LG737532101**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **11.86 X 8.30 X 5.07 MM**

#### GRADING RESULTS

Carat Weight **3.10 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

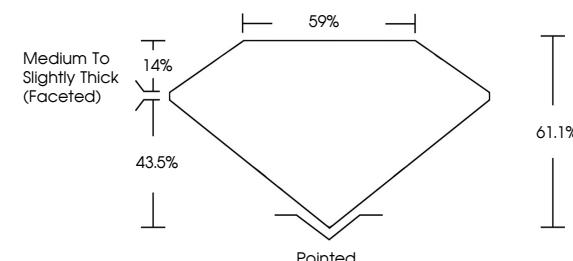
Symmetry **EXCELLENT**

Fluorescence **NONE**

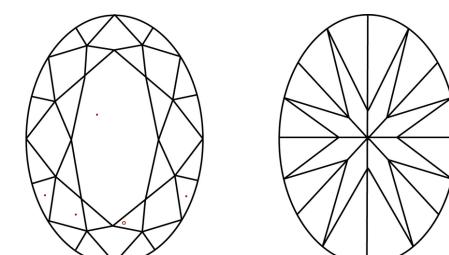
Inscription(s) **IGI LG737532101**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

[www.igi.org](http://www.igi.org)

LG737532101  
Report verification at [igi.org](http://igi.org)

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#### MEASUREMENTS

**3.10 CARATS**

Carat Weight

**D**

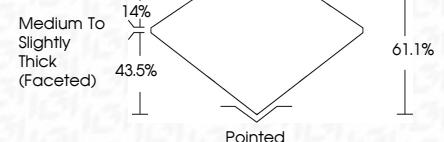
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**VS 1**

Clarity Grade



Sample Image Used



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**IGI**

September 24, 2025	IGI Report No. LG737532101	OVAL BRILLIANT	3.10 CARATS	D	VS 1	61.1%	59%	Medium to Slightly Thick (Faceted)	Pointed	Excellent	Excellent	None	Type IIa
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